

Notice of References Cited	Application/Control No. 10/723,472	Applicant(s)/Patent Under Reexamination CHEN, FENG	
	Examiner Patrick G. Wamsley	Art Unit 2819	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,867,721	03-2005	Lin, Chia-Liang	341/144
	B	US-6,803,869	10-2004	Melanson et al.	341/143
	C	US-6,784,816	08-2004	Melanson et al.	341/143
	D	US-6,738,004	05-2004	Melanson, John L.	341/143
	E	US-6,737,999	05-2004	Schreier, Richard	341/118
	F	US-6,697,004	02-2004	Galton et al.	341/144
	G	US-6,697,003	02-2004	Chen, Feng	341/143
	H	US-6,611,221	08-2003	Soundarapandian et al.	341/143
	I	US-6,535,155	03-2003	Ruha et al.	341/144
	J	US-6,304,608	10-2001	Chen et al.	375/252
	K	US-5,406,283	04-1995	Leung, Bosco	341/143
	L	US-4,193,118	03-1980	Nash et al.	708/445
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Rombouts et al, "A Study of Dynamic Element-Matching Techniques for 3-Level Unit Elements," November 2000, IEEE Transactions on Circuits and Systems, Vol. 47, No. 11, P. 1177-1187.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.